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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

John M. de Larios

Application No. 10/608,871

Filed: June 27, 2003

For: METHOD AND APPARATUS FOR

REMOVING A TARGET LAYER FROM A

FEB 1 8 2005

SUBSTRATE USING REACTIVE GASES

Group Art Unit: 1746

) Examiner: Unassigned

Atty. Docket No. LAM2P422

Date: February 15, 2005

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria,

VA 22313-1450 on February 15,200

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §§1.56 AND 1.97(c)

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached form PTO/SB/08a may be material to examination of the above-identified patent application. Copies of the references listed in the attached form PTO/SB/08a are enclosed, in accordance with 37 CFR.1.98(a)(2).

Applicants identify these references in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make these references of official record in this application.

This Information Disclosure Statement (IDS) is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

This Information Disclosure Statement is believed to be filed before the mailing date of a first office action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. <u>LAM2P422</u>).

Respectfully submitted,

MARTINE PENILLA & GENCARELLA, LLP

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Customer Number 25920

LAM2P422

Complete if Known **Application Number** 10/608,871 Substitute for form 1449/PTO FEB 1 8 2005 Filing Date June 27, 2003 INFORMATION TOUS CLOS John M. de Larios First Named Inventor STATEMENT BY APPLIA 1746 Art Unit (Use as many sheets as necessary) Unassigned **Examiner Name**

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U.S. Patent Documents

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Examiner Initials	Cite No. ¹	Document Number Number-Kind Code ^{2 (if known)}	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear	
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Foreign Patent Documents

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Examiner	Date	
Signature	Considered	

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Substitute for form 1449/PTO					App	Application Number			10/816,337				
INFORMATION DISCLOSURE							Filing Date			March 31, 2004			
							First Named Inventor				John M. de Larios		
STATEMENT BY APPLICANT							Art Unit			1744			
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